



PATENT APPLICATION

28788
#10/2003 (2)
7/8/03 Hayes

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Commissioner for Patents and Trademarks
Washington, D.C. 20231

On June 16, 2003, by Delbert J. Barnard.

Signature:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2878
Examiner: S. Lee
Applicant: Ger Van den Engh
Serial No.: 09/847,466
Filed: May 1, 2001
Entitled: APPARATUS FOR DETERMINING RADIATION BEAM
ALIGNMENT
Date: Monday, June 16, 2003

RECEIVED
JUN 23 2003
TECHNOLOGY CENTER 2800

PETITION FOR EXTENSION OF TIME

The Commissioner for Patents

Washington, D.C. 20231

Sir:

It is respectfully requested that the due date for filing a Response to the Office Action dated January 15, 2003, be amended from April 15, 2003 to June 15, 2003.

A check for the extension fee of \$205.00 as set forth in 37 C.F.R. 1.17(a) is enclosed. Please charge any additional extension fees to Deposit Account No. 02-0915. Two duplicate copies of this Petition are enclosed.

Respectfully submitted:

Ger Van den Engh

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